

EXPEDITED PROCEDURE – EXAMINING GROUP 2822

S/N 10/623,788

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Leonard Forbes et al.

Examiner: Pamela E. Perkins

Serial No.: 10/623,788

Group Art Unit: 2822

Filed: July 21, 2003

Docket No.: 1303.109US1

Title: STRAINED SEMICONDUCTOR BY FULL WAFER BONDING

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

*entered by
RCE filed
6/26/07
gauris 6/29/07*

In response to the Final Office Action dated March 29, 2007, please amend the application as follows: